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**ATTENTION: BOX AFTER FINAL
RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 2823**

PATENT
Customer No. 22,852
Attorney Docket No. 08244.0026

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Sun-oo KIM

Application No.: 09/739,743

Filed: December 20, 2000

For: METHOD FOR
MANUFACTURING INTERLAYER
DIELECTRIC LAYER IN A
SEMICONDUCTOR DEVICE

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) Group Art Unit: 2823
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) Examiner: W. Coleman
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Assistant Commissioner for Patents
Washington, DC 20231

Sir:

RESPONSE AND REQUEST FOR RECONSIDERATION AFTER FINAL

In reply to the Final Office Action of August 7, 2002, and pursuant to 37 C.F.R.
§ 1.116, Applicant requests reexamination and reconsideration of the subject
application.

REMARKS

In the Final Office Action, the Examiner rejected claims 1-7 under 35
U.S.C. § 103(a) as unpatentable over Kirchoff et al., U.S. Patent No. 6,057,250
("Kirchoff") in view of Lu et al., U.S. Patent No. 6,265,303 ("Lu"). In response, Applicant

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